



PATENT
2927-0155P

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Mitsunori Mike et al.

Conf: 6433

Application No.: 10/681,156

Art Unit: 2635

Filed: October 9, 2003

Examiner: Jayesh A. Patel

For: METHOD AND APPARATUS OF
MEASURING ROTATIONAL AND
FLIGHT CHARACTERISTICS OF SPHERE

REQUEST FOR RECONSIDERATION

REQUEST FOR WITHDRAWAL OF FINAL REJECTION

REPLY UNDER 37 C.F.R. § 1.116

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action mailed May 30, 2007, the period for response being extended by one (1) month, the following remarks are respectfully submitted in connection with the above-identified application:

This Paper includes Claims as Previously Presented and Remarks.

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10/15/07